

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))					Docket No. RAC0082	
In Re Application Of: Alexander HAUSER et al.						
Application No. 10/555141	Filing Date	Examiner	Customer No. 00832	Group Art Unit	Confirmation No.	
Title: METHOD FOR TEXTURING SURFACES OF SILICON WAFERS						
Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450						
37 CFR 1.97(b)						
1. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.						
37 CFR 1.97(c)						
2. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:						
<div style="margin-left: 40px;"> <input type="checkbox"/> the statement specified in 37 CFR 1.97(e); </div>						
OR						
<div style="margin-left: 40px;"> <input type="checkbox"/> the fee set forth in 37 CFR 1.17(p). </div>						

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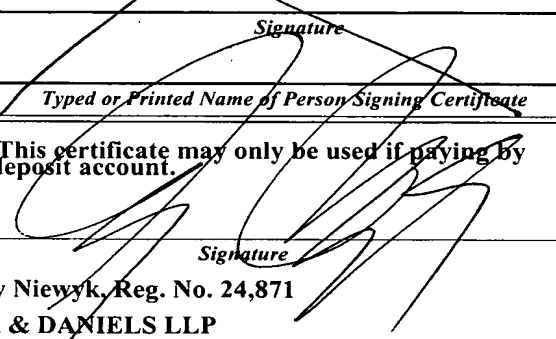
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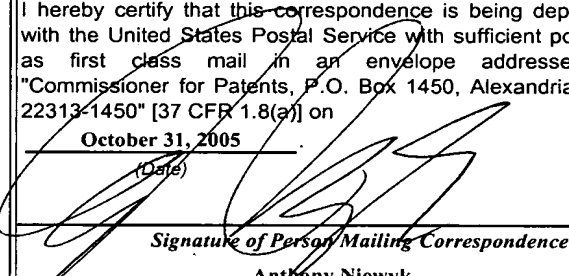
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Dated: October 31, 2005

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CC:

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional) RAC0082	
	Applicant(s) Alexander HAUSER et al.	
	Filing Date	Group Art Unit Unassigned

19/555141

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,309,467	10/30/01	Wochner et al.			

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		JP05291215	11/5/93	Japan Abstract				
		DE 199 62 136A1	6/28/01	Germany w/Abstract				

OTHER DOCUMENTS	(Including Author, Title, Date, Pertinent Pages, Etc.)
	Copy of International Search Report issued in International application number PCT/DE2004/000835 on September 10, 2004

EXAMINER	DATE CONSIDERED
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